

SAU 2812/8

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hongyong Zhang Art Unit : 2812
Serial No.: 09/362,808 Examiner :
Filed : July 28, 1999
Title : METHOD OF FABRICATING SEMICONDUCTOR DEVICE

Assistant Commissioner for Patents
Washington, D.C. 20231

TRANSMITTAL LETTER AND PETITION FOR AUTOMATIC EXTENSION

Correspondence relating to this application is enclosed.
The required fees are computed below. Please apply any charges
not covered, or any credits, to Deposit Account No. 06-1050.

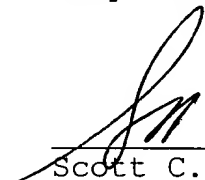
Total Claims	30	-	20	=	10	\$180
Independent	6	-	3	=	3	\$234

TOTAL FEE DUE \$414

A check for \$414 is attached.

Respectfully submitted,

Date: 1/18/00



Scott C. Harris
Reg. No. 32,030

SCH/smr
Fish & Richardson P.C.
4225 Executive Square, Suite 1400
La Jolla, CA 92037
Telephone: (858) 678-5070
Facsimile: (858) 678-5099

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Signature

Scott C. Harris
Typed or Printed Name of Person Signing Certificate



ATTORNEY'S DOCKET NO.: 07977/088002/US3155D1

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Art Unit : 2812
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PRELIMINARY AMENDMENT

Sir:

Prior to initial examination, kindly amend the above
identified divisional application as follows:

In the Claims:

Please amend claim 1 as follows:

1. (Amended) [A method of fabricating a thin-film
transistor comprising a gate region having a gate electrode made
of a material capable of being anodized and source-drain regions
made of a semiconductor, said method comprising the steps of:

A.I.
Cont'd
sub
C1

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01 FC:103
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180.00 OP
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Signature

Typed or Printed Name of Person Signing Certificate

1-18-00

James Christy

James Christy